## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RE APPLICATION OF: Sang H. Ahn et al.

§ GROUP ART UNIT: 1756

SERIAL NO.: 10/724,454

2 4 2006

EXAMINER: D. Chacko Davis

FILED: November 28, 2003

§

FOR: MAINTENANCE OF PHOTORESIST ADHESION AND ACTIVITY ON THE SURFACE OF

§ Attorney Docket No.:

AM-8472

DIELECTRIC ARCS FOR 90 nm FEATURE SIZES

Date: May 24, 2006

## AMENDMENT "B" UNDER 37 C.F.R. § 1.111

Hon. Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This Amendment "B" is in response to the Office Action mailed January 24, 2006, having a shortened statutory period for response of April 24, 2006. A Petition for a One Month Extension of Time to respond accompanies this Amendment "B", to extend the time for response through May 24, 2006.

Claims 1 - 40 are pending in the application. Claims 1 - 29, 39 and 40 are withdrawn under a restriction requirement. Claims 30 - 38 are rejected.

## **CERTIFICATE OF MAILING UNDER 37 CFR § 1.10**

I hereby certify that this paper and any documents said to accompany this paper are being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EV 812431659 US in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: May 24, 2006

Claims 30 - 38 are rejected under 35 U.S.C. § 102(e) as being unpatentable over U.S. Patent No. 6,927,178 to Kim et al.

Please amend the application as follows.